



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

November 10, 2025	
IGI Report Number	LG739586080
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	PRINCESS CUT
Measurements	6.94 X 6.94 X 4.96 MM

GRADING RESULTS

Carat Weight	2.05 CARATS
Color Grade	FANCY YELLOW
Clarity Grade	VS 1

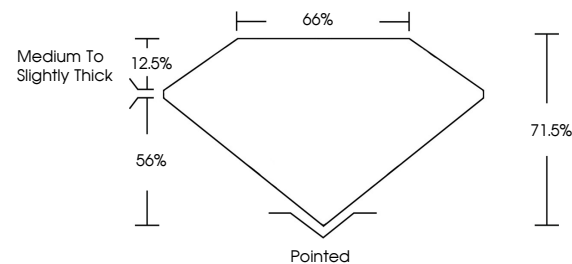
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	16 LG739586080

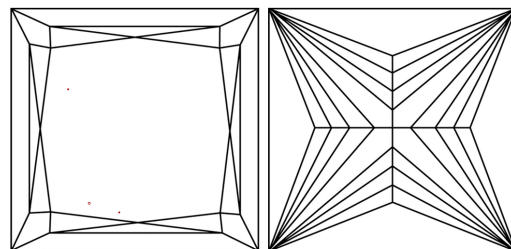
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

LG739586080
Report verification at igi.org

PROPORTIONS

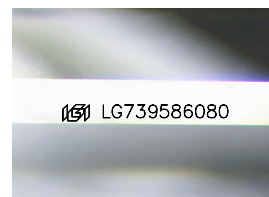


CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

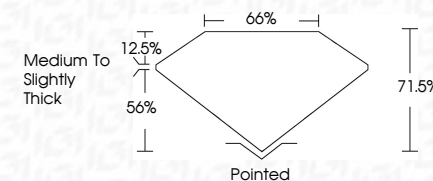
CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

LABORATORY GROWN DIAMOND REPORT



November 10, 2025	
IGI Report Number	LG739586080
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	PRINCESS CUT
Measurements	6.94 X 6.94 X 4.96 MM
GRADING RESULTS	
Carat Weight	2.05 CARATS
Color Grade	FANCY YELLOW
Clarity Grade	VS 1



ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG739586080

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.



© IGI 2020, International Gemological Institute

FD - 10 20

www.igi.org

THIS DOCUMENT WAS PRODUCED WITH THE FOLLOWING SECURITY MEASURES: SPECIAL DOCUMENT PAPER, INK SCREENS, WATERMARK, BACKGROUND DESIGNS, HOLOGRAM AND OTHER SECURITY FEATURES NOT LISTED AND DO EXCEED DOCUMENT SECURITY INDUSTRY GUIDELINE

November 10, 2025
GI Report No LG739586080
PRINCESS CUT

2.06 CARATS	VS 1	Medium To Slightly Thick	Pointed
FANCY YELLOW	71.5%		EXCELLENT
	66%		EXCELLENT
			NONE
			see certificate

Comments:
This Laboratory Grown Diamond was
created by Chemical Vapor Deposition